

H0027362/9930/95675
PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/552,497
Applicant : Neils Richard Hansen
Filed : September 8, 2006
TC/A.U. : 1792
Examiner : Binh X. Tran
Docket No. : H0027362/9930/95675
Customer No. : 00128
Title : METHOD OF
MANUFACTURING GAS
DIFFUSION ELECTRODES

Confirmation No.: 2271

**CERTIFICATE OF MAILING BY
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Date: December 1, 2009

AMENDMENT UNDER RULE 37 CFR § 1.112

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

In conjunction with an Examiner Interview of December 1, 2009, the Applicant responds as follows: